



SAND2011-4359C

Magnetically Appplied Pressure-Shear (MAPS):

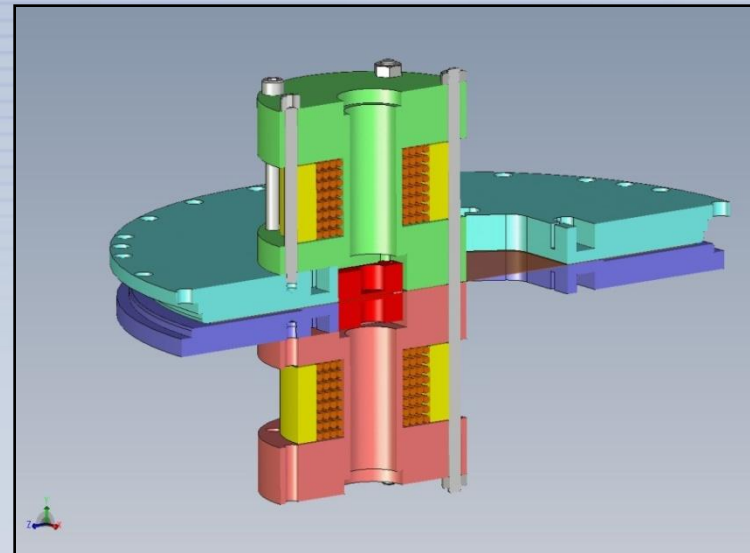
A Novel Technique for Strength Measurement

C. Scott Alexander

James R. Asay

Sandia National Laboratories

Albuquerque, NM



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Outline

- **Motivation**
 - Why do we need a new measurement technique?
- **Overview of the MAPS approach to strength measurement**
 - Principles of operation
 - Implementation on the Veloce Small Pulser
 - Design considerations
- **Experimental results**
 - Initial measurements on aluminum
 - 2D material response of zirconia
- **Summary**

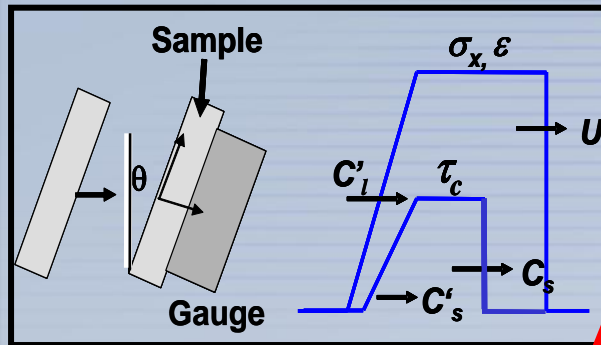
For further details:

C.S. Alexander, J.R. Asay and T.A. Haill, *JAP*, **108**, 126101 (2010).

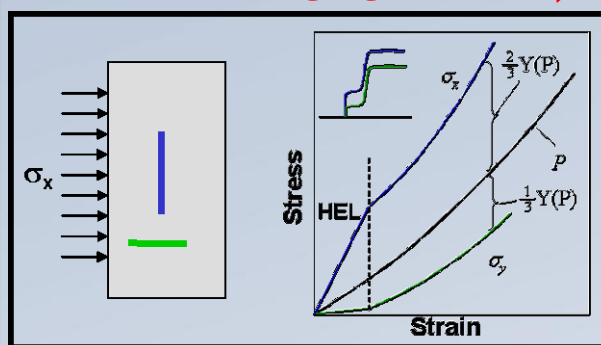


Motivation: Existing strength measurement techniques have limitations at high pressure

Oblique impact



Lateral gauges



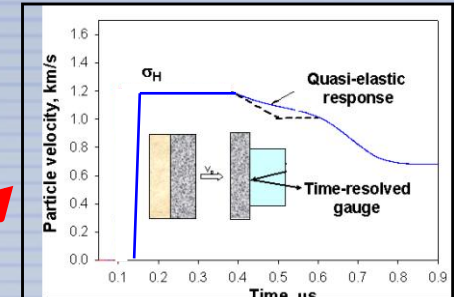
Limited to low P
(<200 kbar)

Requires assumptions

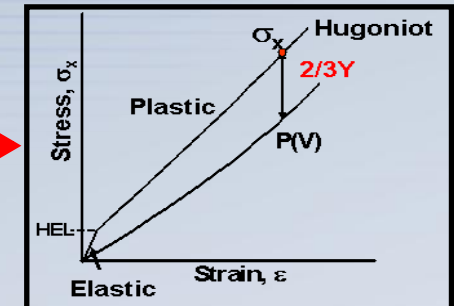
Large uncertainties

Requires accurate models
which are unknown

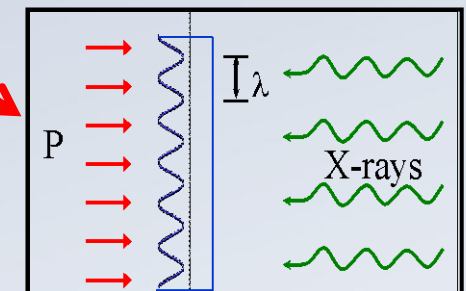
Wave Profile



Stress Difference



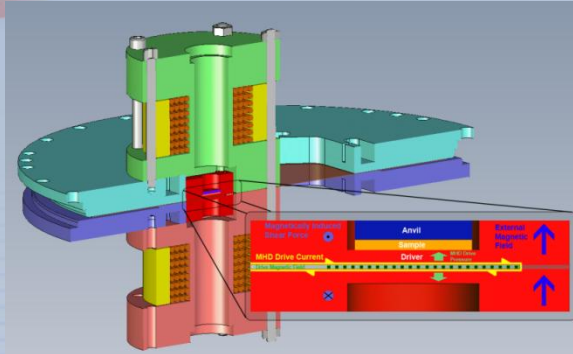
Rayleigh-Taylor



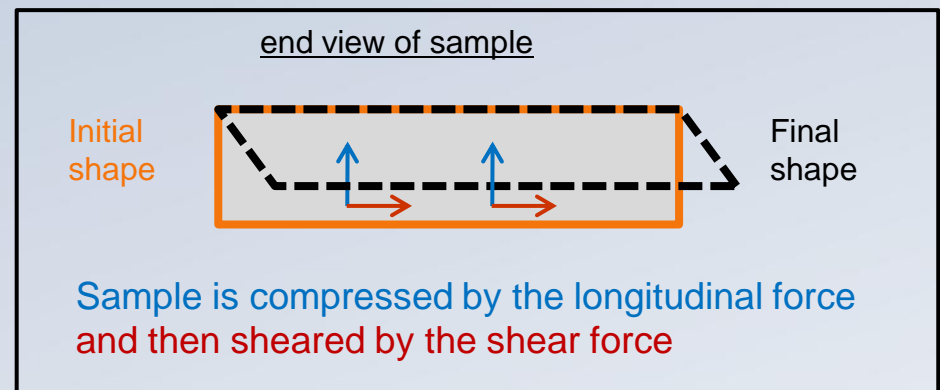
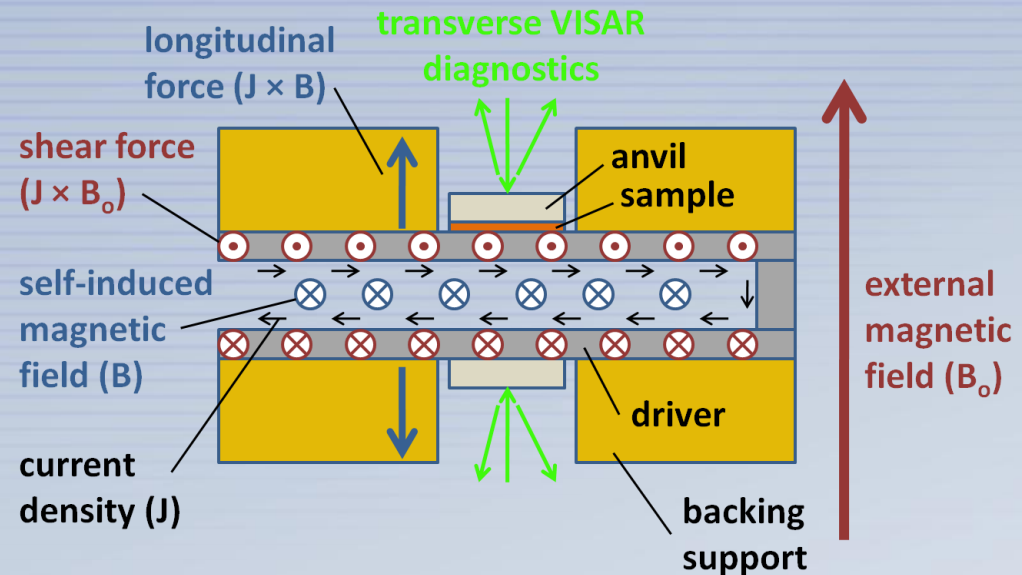
There is a need for improved strength measurement capability at high pressures



Operating principles behind the MAPS technique

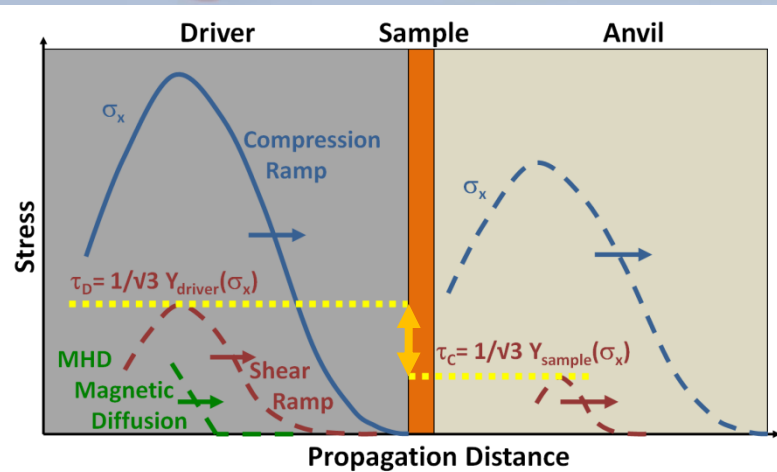


1. A pulsed power drive generates current (J) in parallel panels and induces a magnetic field (B) between the panels
2. The interaction $J \times B$ produces a pressure wave which compresses the material
3. A large (10T, $\sim 10^5$ times Earth's field) external magnetic field (B_0) is applied
4. The interaction $J \times B_0$ produces a shear wave in the driver (panel)
5. The generated shear wave propagates through the sample material where it is truncated to a level determined by the sample strength
6. Specialized VISAR interferometry is used to record both longitudinal and transverse particle velocities (NOTE: probe orientation is transverse to plane of page)
7. Pressure and strength are calculated from the measured particle velocities



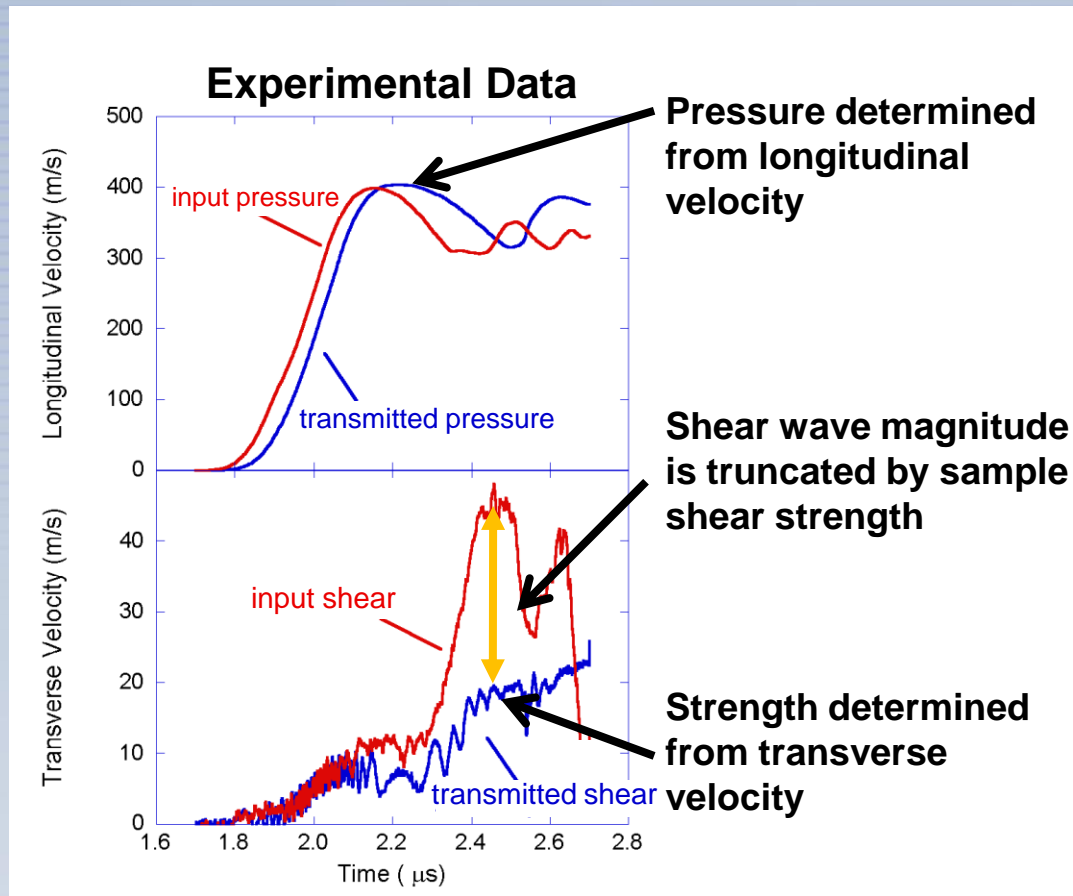


MAPS: a novel method to measure shear strength at high pressure



- Sample is compressed by longitudinal wave to high pressure
- Shear wave is produced in driver by interaction of drive current and an external magnetic field
- Maximum shear that can be transmitted through sample limited by von Mises yield criterion

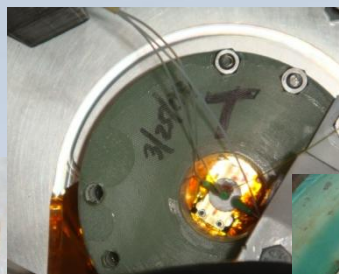
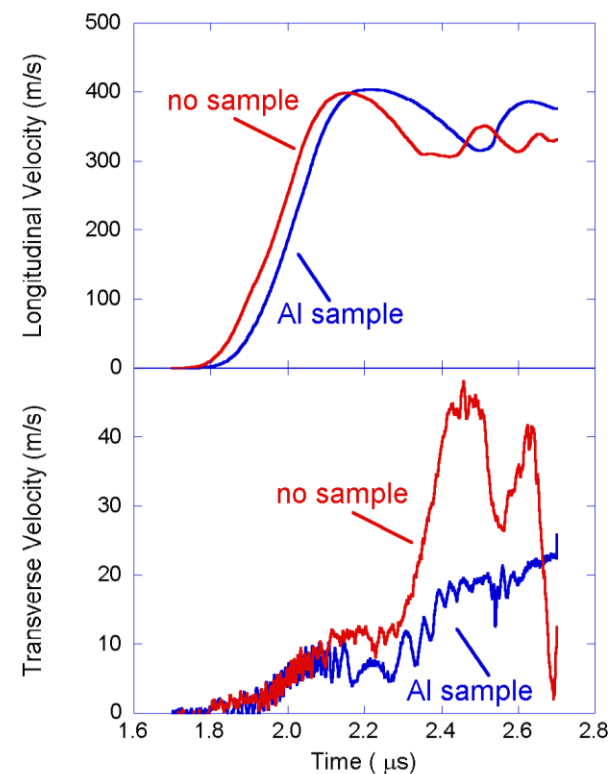
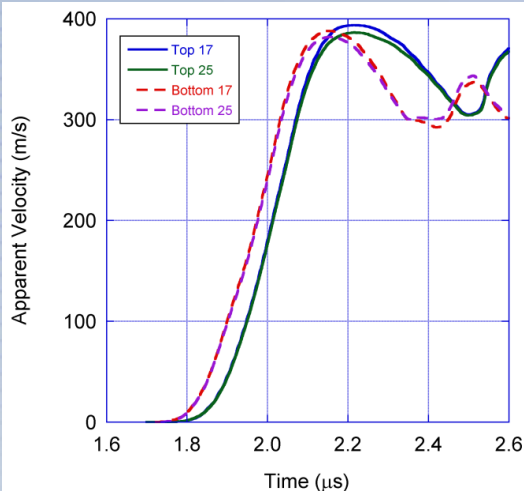
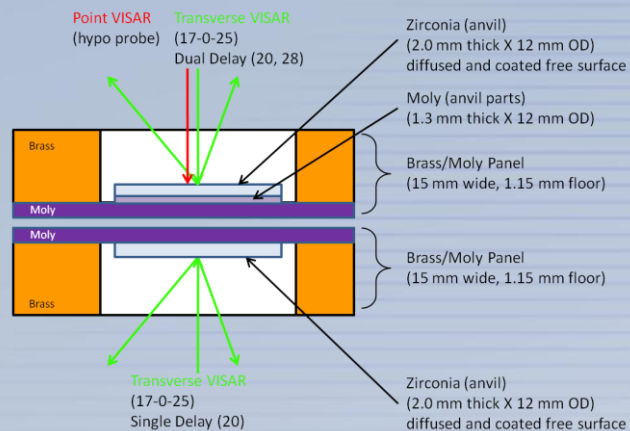
$$\tau \leq 1 / \sqrt{3} Y(\sigma_x)$$



- Strength determined directly from longitudinal and shear particle velocities measured at anvil free surface using VISAR

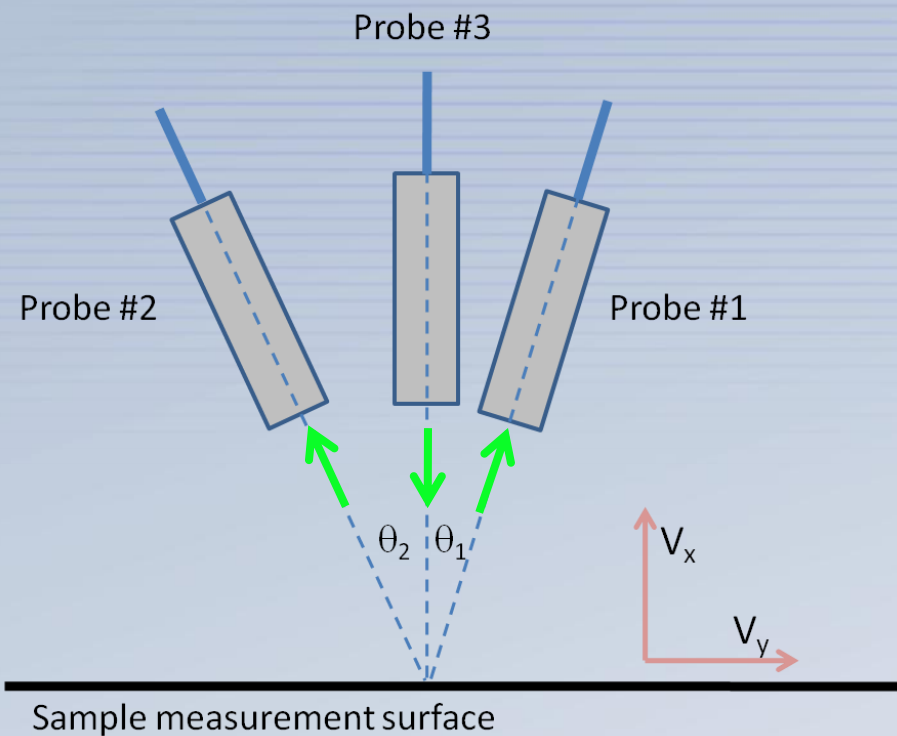


Initial MAPS experiments measure aluminum strength at 8.85 GPa





Transverse VISAR velocity determination



$$v_1^* = \frac{\cos(\theta_1) + 1}{2} v_x - \frac{\sin(\theta_1)}{2} v_y$$

$$v_2^* = \frac{\cos(\theta_2) + 1}{2} v_x + \frac{\sin(\theta_2)}{2} v_y$$

$$G_1 = \frac{1}{2} (\cos \theta_1 + 1)$$

$$G_2 = \frac{1}{2} (\sin \theta_1)$$

$$G_3 = \frac{1}{2} (\cos \theta_2 + 1)$$

$$G_4 = -\frac{1}{2} (\sin \theta_2)$$

$$F_1 = G_1 - \left(\frac{G_1 G_2}{G_4} \right)$$

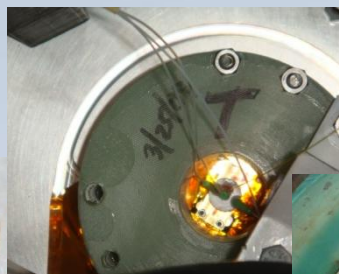
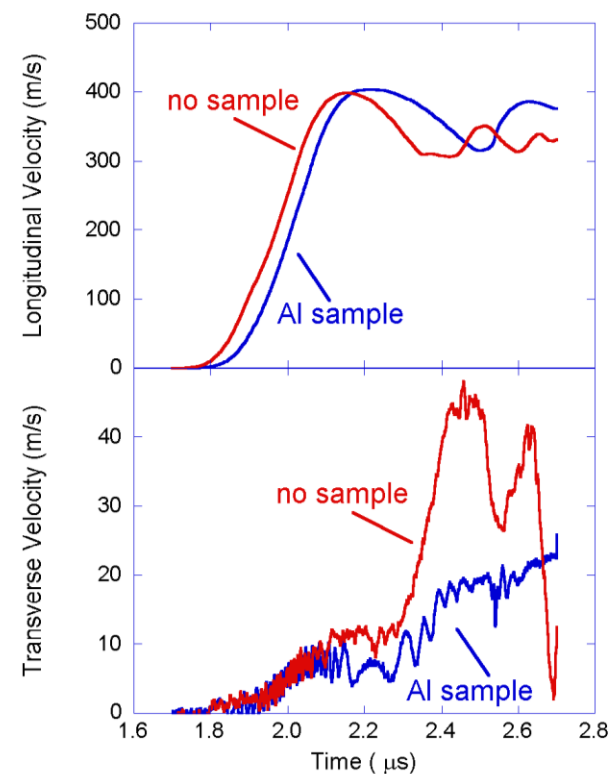
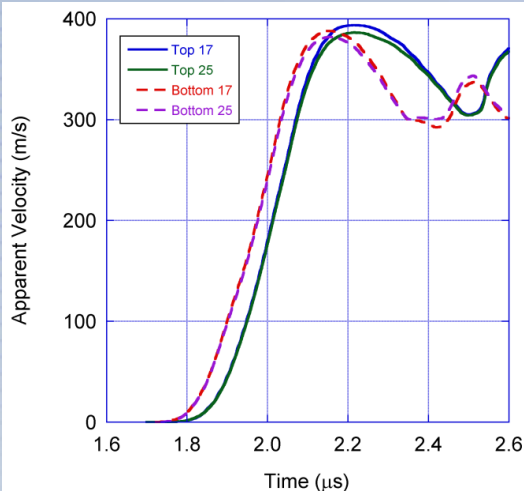
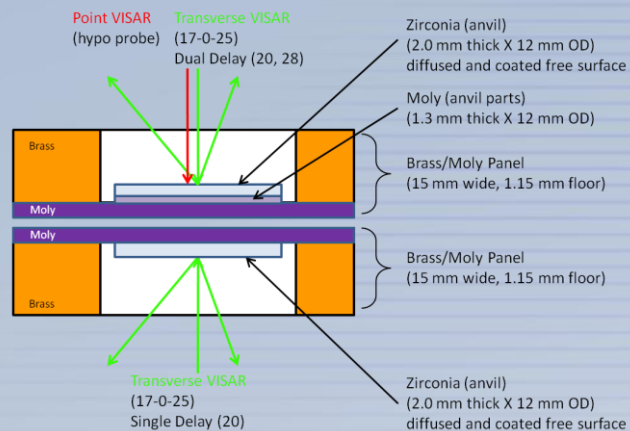
$$F_2 = \left(\frac{G_2}{G_1 G_4 - G_2 G_3} \right)$$

$$v_x = \left(\frac{v_1^* - F_2 v_2}{F_1} \right)$$

$$v_y = \left(\frac{v_2^* - F_3 v_x}{G_4} \right)$$



Initial MAPS experiments measure aluminum strength at 8.85 GPa





Pressure and shear are calculated directly from measured free surface velocities

$$\sigma = \rho_o C_L u_p$$

$$\sigma = (6.07 \text{ g/cc}) (7.33 \text{ km/s}) \frac{1}{2}(0.398 \text{ km/s})$$

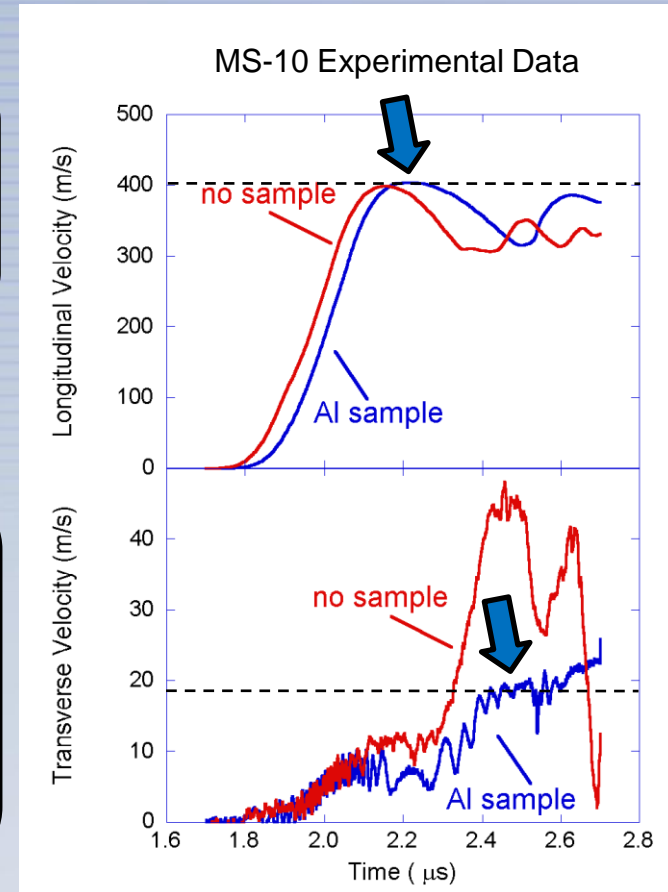
$$\sigma = 8.85 \text{ GPa}$$

$$\tau = \rho_o C_\tau u_p$$

$$\tau = (6.07 \text{ g/cc}) (4.105 \text{ km/s}) \frac{1}{2}(0.0187 \text{ km/s})$$

$$\tau = 0.233 \text{ GPa}$$

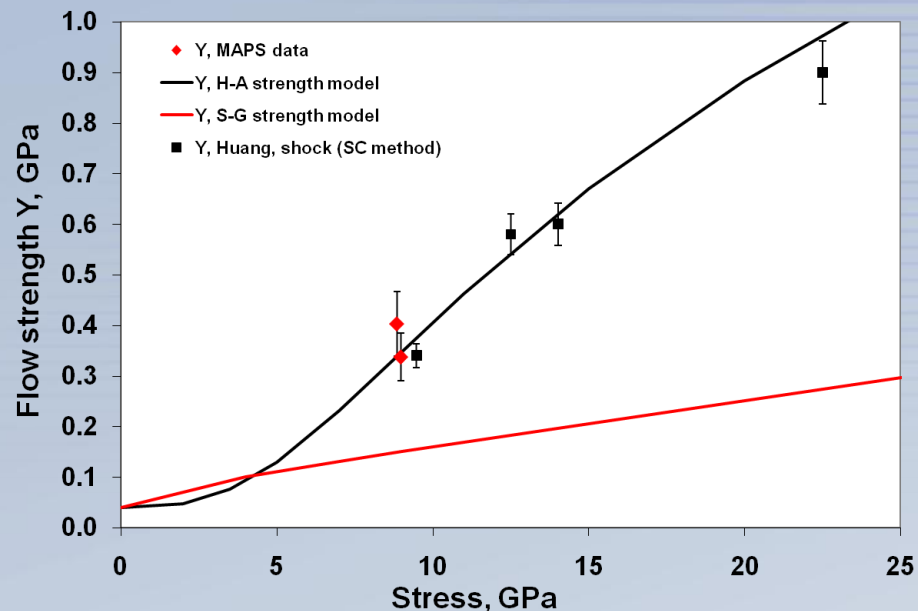
$$Y = \sqrt{3} \tau = 0.404 \text{ GPa} \\ \pm 0.065 (16\%)$$





Initial MAPS data comparison with established strength data is excellent

Aluminum



- Accuracy and configuration being improved – goal is $\delta Y \leq 5\%$ at Mbar pressures
- Technique easily discriminates between strength models

H. Huang and J.R. Asay, *J. Appl. Phys.* **98**, 033524 (2005)

D.J. Steinberg, S.G. Cochran, and M.W. Guinan, *J. Appl. Phys.* **51**, 1498 (1980)

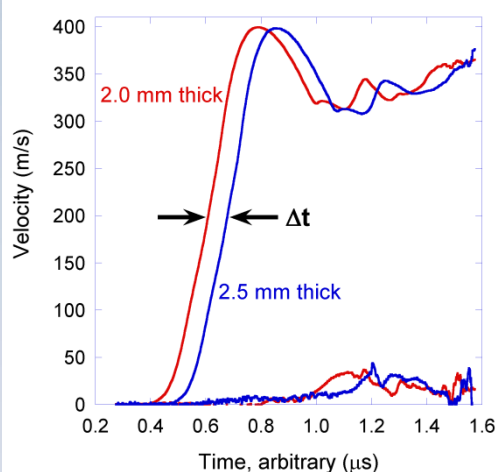
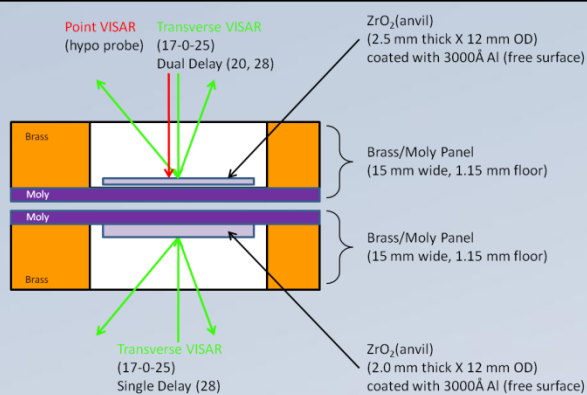
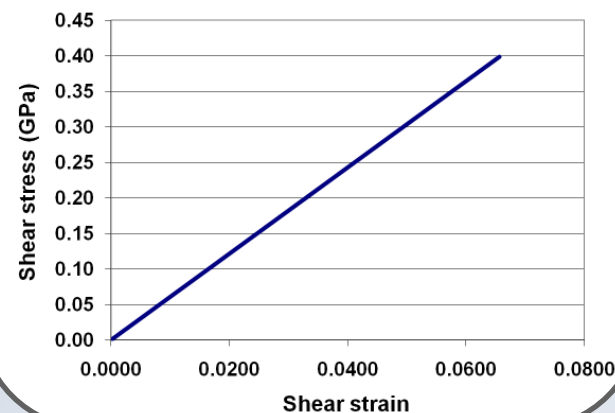
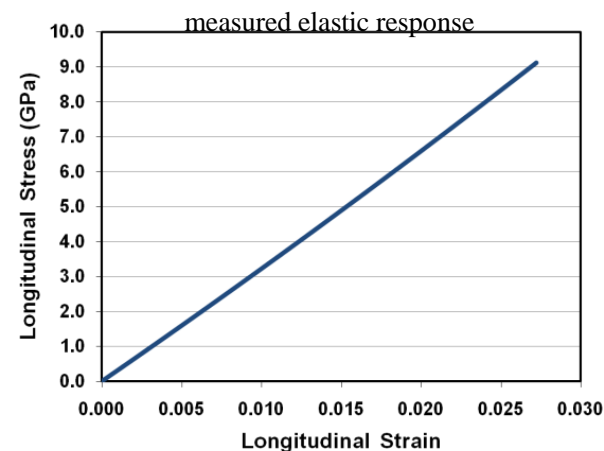


Additional utility of the MAPS experimental configuration: 2D model validation data

New multi-dimensional capability for enhanced model validation!

- Has been applied to verify elastic response of zirconia anvil material to ~9 GPa

Zirconia (YTZP)





Summary

- MAPS is a novel technique to directly measure material strength at high pressure
- MAPS capability has been demonstrated
 - 2 Al strength shots
 - 1 ZrO₂ shot
- Work is ongoing to demonstrate MAPS on additional materials at modest pressures
- Transition to Z is in progress (expected CY2012) to extend to higher pressures

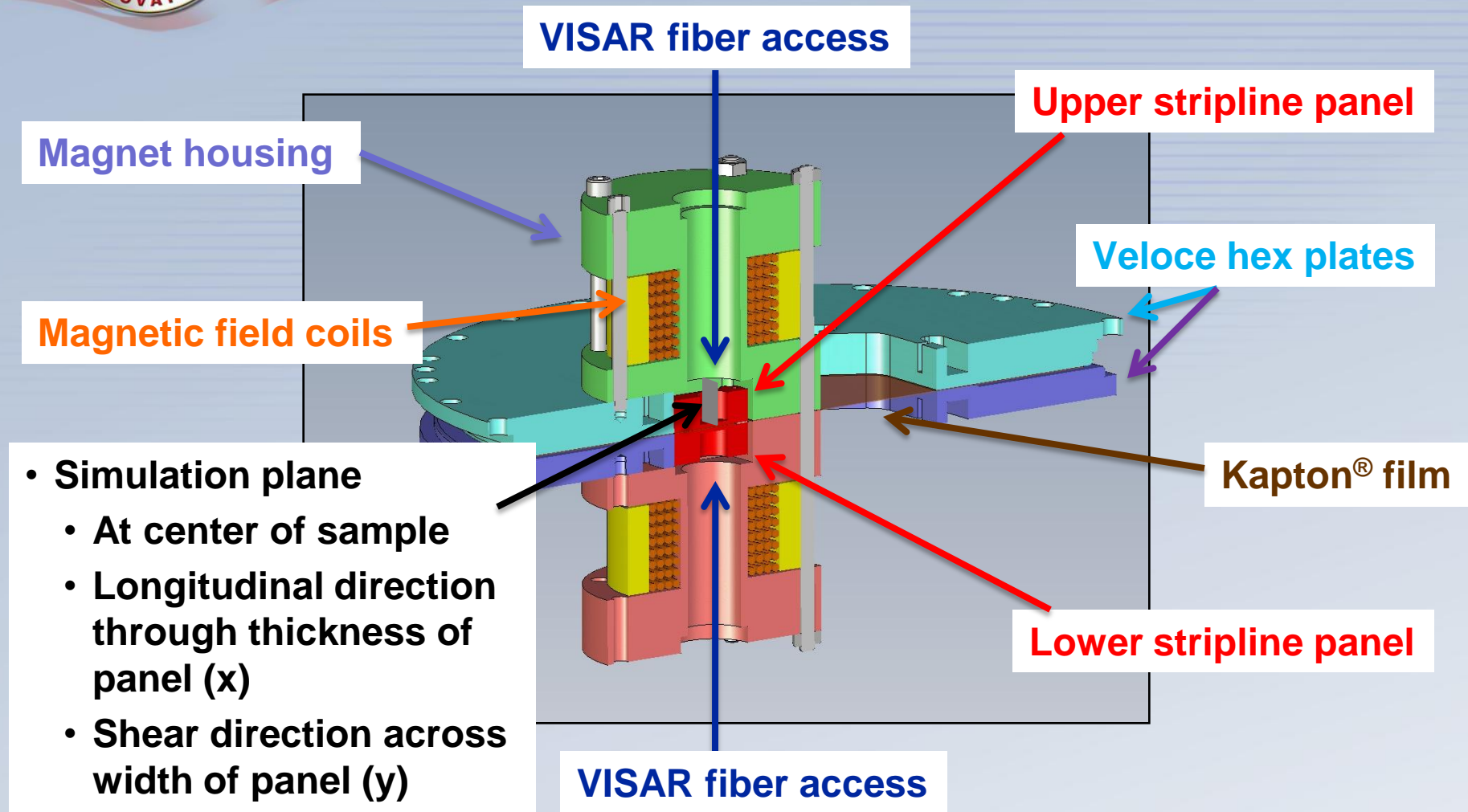
End of show



- **Back-up Slides**

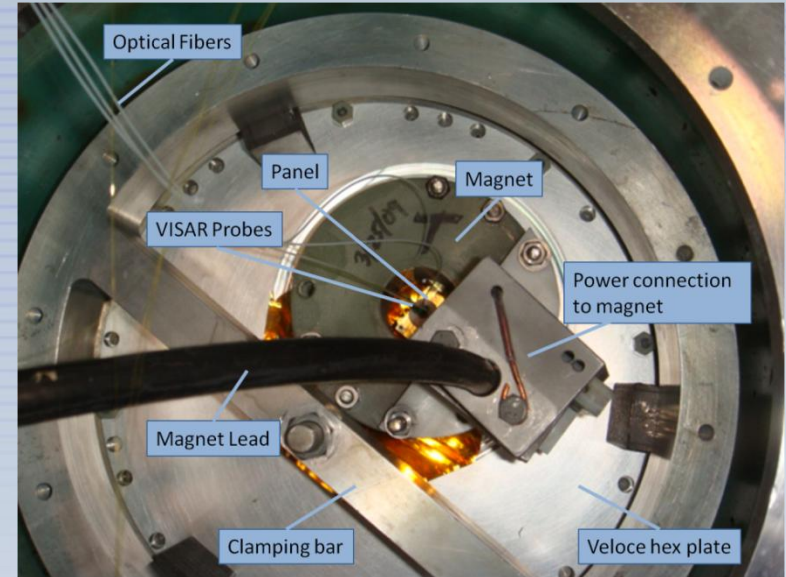
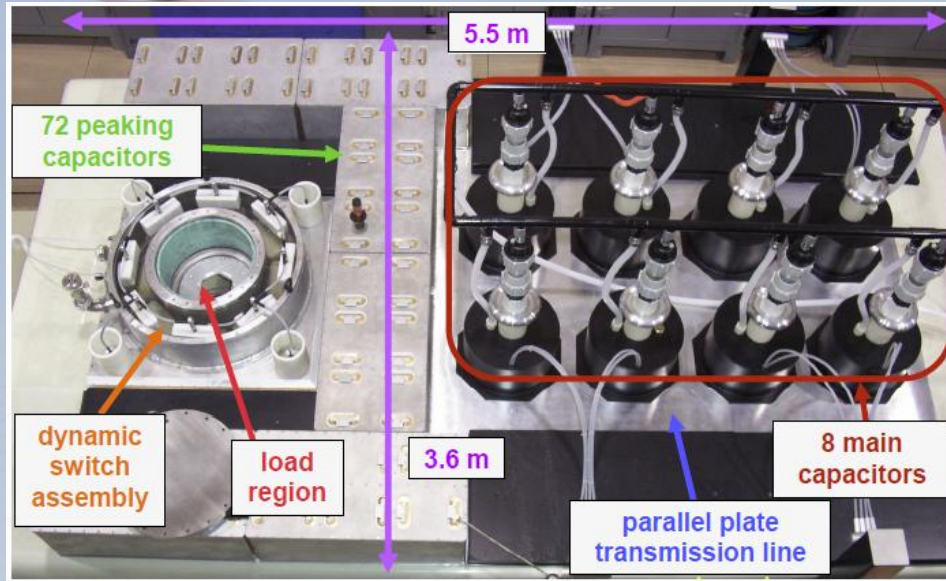


Notional View of the MAPS Experimental Implementation

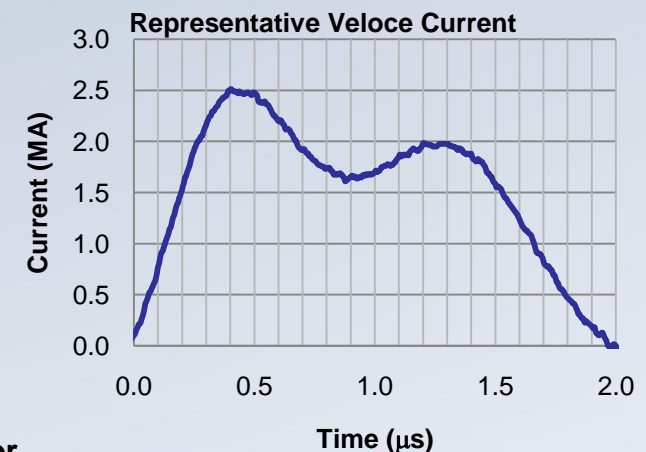




MAPS Experiments on the Veloce Small Pulser



- **MAPS developed on SNL's Veloce pulser**
 - 2.5 MA, 2 μ s current pulse
 - ~10 GPa sample pressures
 - 10 mm diameter, 50-100 μ m thick sample sizes





Design of Driver Panel: Desired Properties of Driver Material

- **High Yield Stress**
 - Shear stress generated by $J \times B_0$ limited by driver yield stress
- **High Melt Temperature**
 - Remain solid
 - Efficiently couple magnetic forces into driver
- **High Conductivity (Low Resistivity)**
 - Increase drive current for given capacitor bank charge
 - Inhibit magnetic diffusion (MHD drive) into driver
- **Low Density**
 - Magnetic forces able to accelerate panels



Design of Anvil Panel: Desired Properties of Anvil Material

- **High Yield Stress**
 - Do not limit material stresses received from test sample
 - Anvil strength must exceed sample strength at measurement pressures
 - Propagate high longitudinal and shear stresses (velocities) to free surface with little attenuation
 - Avoid spall
- **High Melt Temperature**
 - Remain solid
- **Low Conductivity (High Resistivity)**
 - Allow faster permeation of external B_0 field
 - Inhibit current flow into anvil

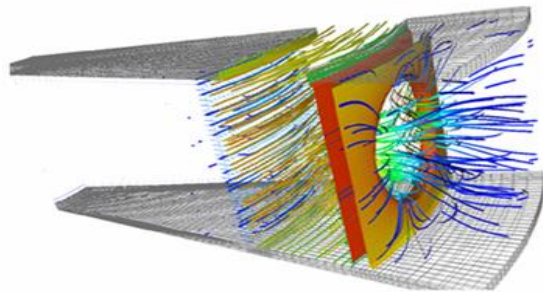
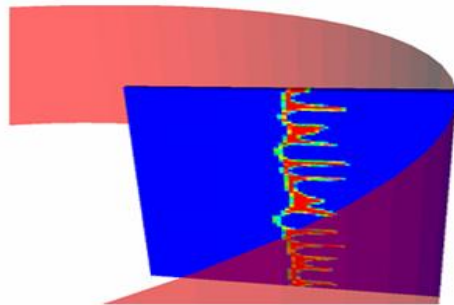
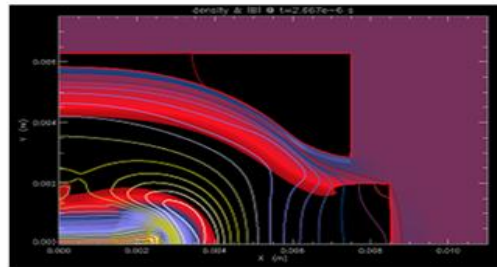


Materials of Interest: Initial Material Parameters

Z	Material	Density (g/cm ³)	Melt Temperature (K)	Yield Stress (GPa)	Poisson Ratio	Conductivity (μΩ*cm) ⁻¹
13	Aluminum	2.7	933	0.29	0.33	0.377
22	Titanium	4.54	1933	0.85	0.30	0.024
26	Iron (304 SS) (V-250 SS)	7.87	1808	(0.34) (1.56)	(0.283) (0.283)	0.103
29	Copper	8.96	1356	0.12	0.33	0.598
42	Molybdenum	10.22	2890	1.6	0.375	0.192
47	Silver	10.50	1235	0.05	0.37	0.629
73	Tantalum	16.65	3269	0.77	0.30	0.080
74	Tungsten	19.3	3683	2.20	0.30	0.177
79	Gold (Cu)	19.32	1338	0.02 (0.63)	0.42	0.425
92	Uranium	18.95	1405	0.40	0.30	0.033
	Diamond	3.52	~ 3820	35 - 91	0.104	< 10 ⁻⁸
	Sapphire	3.97	~ 2326	14 - 18	0.18 – 0.29	< 10 ⁻¹
	Zirconia (YTZP)	6.026	~ 2988	8.5	0.3124	< 10 ⁻⁸



Physics Models in ALEGRA - a 3D/2D Radiation Magneto-Hydrodynamics code



- 2D (RZ & XY) and 3D (XYZ)
- Unstructured Finite-Element Based
- Eulerian/Lagrangian/ALE
- Object Oriented
- Massively Parallel
- Isentropic Multi-Material
- Coupled Physics
 - Hydrodynamics
 - Magnetics
 - Thermal Conduction
 - Radiation (Multi-Group Diffusion & IMC)
- Material Models
 - LANL Sesame & other EOS
 - Lee-More-Desjarlais (LMD) Conductivity
 - XSN & Propaceos Opacities

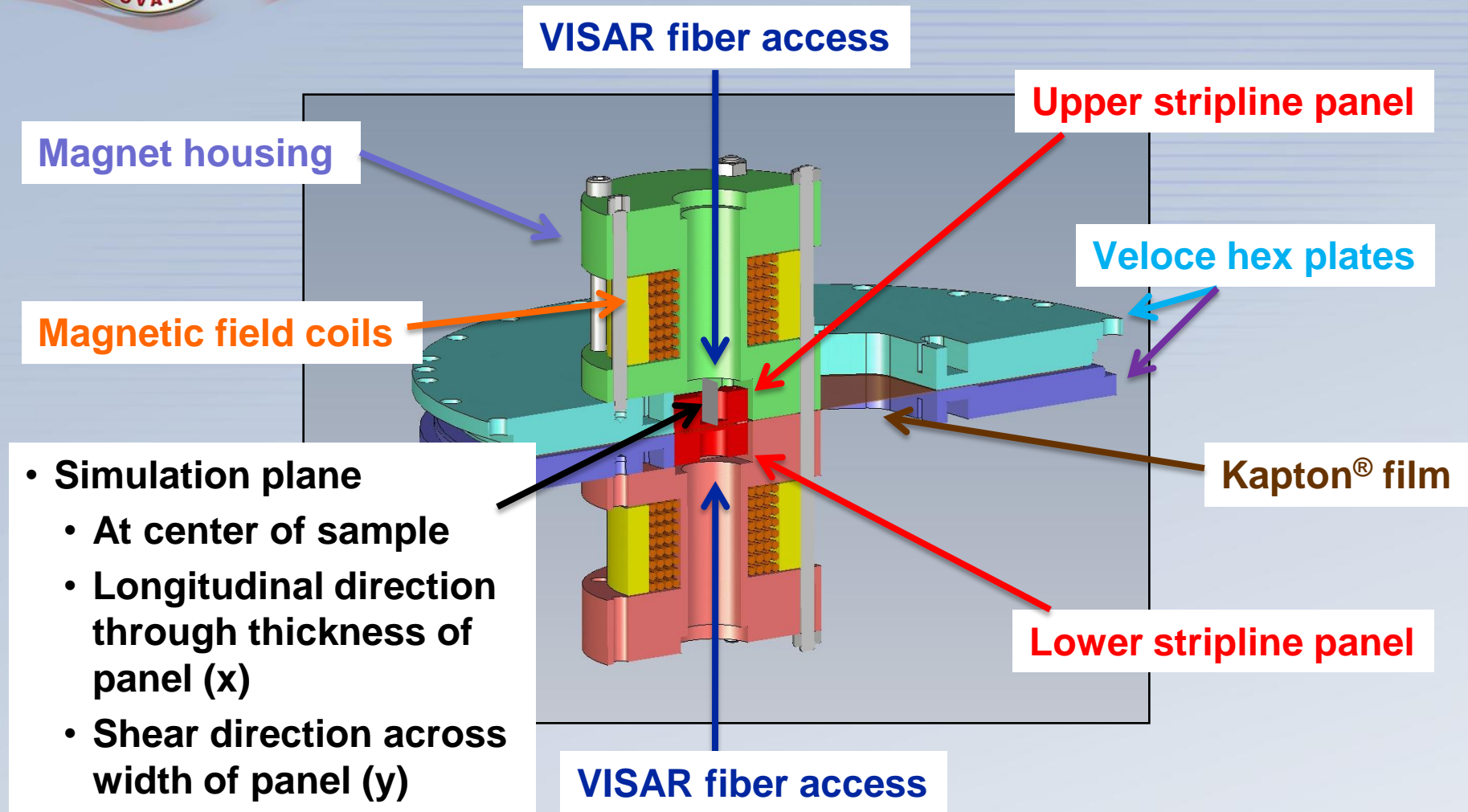


ALEGRA Material Models

Material	Equation of State	Strength Model	Conductivity Model
Molybdenum	KEOS Sesame ANEOS 2984	CTH Elastic-Plastic Steinberg-Guinan	Lee-More-Desjarlais (LMD)
Aluminum	SNL Sesame 3720	CTH Elastic-Plastic Steinberg-Guinan	Lee-More-Deslarlais (LMD)
Zirconia	Mie-Gruneisen Us-Up EOS	CTH Elastic-Plastic High Yield Strength	Constant Electric & Thermal Conductivity



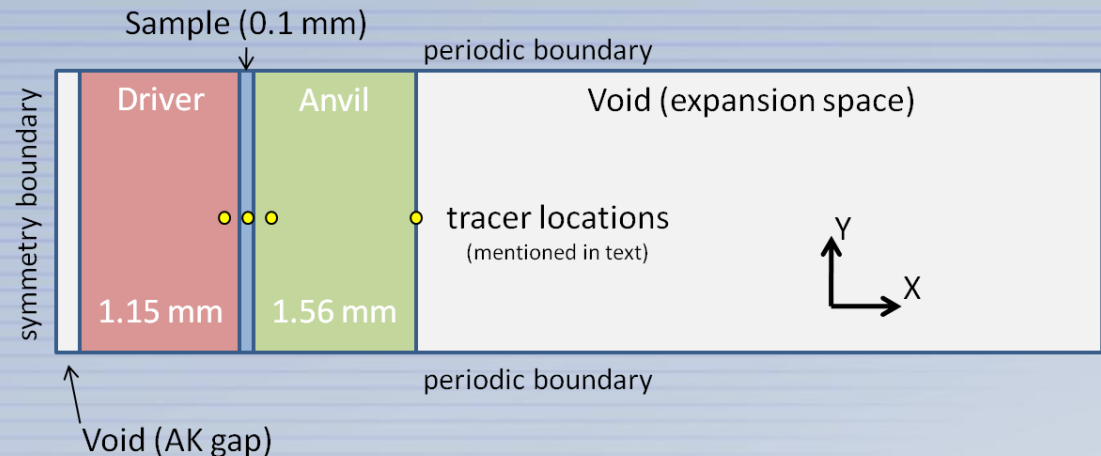
Notional View of the MAPS Experimental Implementation





ALEGRA Modeling of MAPS Experiments

$$B(t) = f(t) \frac{\mu_0 I(t)}{W + G}$$

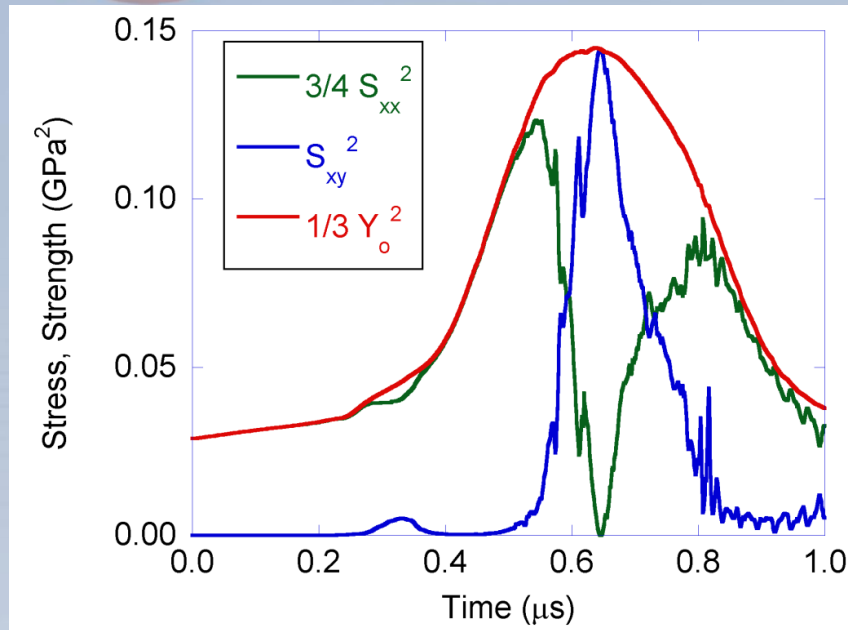


- Assume sufficient uniformity near center of sample
- 2D Cartesian Eulerian mesh
 - 5 - 10 μm cell size
- Periodic mesh in transverse or shear direction (Y)
- Uniform, static B_0 magnetic field in longitudinal direction (X)
- Current driven tangent magnetic field applied at AK gap

- Stripline BC
 - W = panel width
 - G = AK gap
- Current density out of the plane of mesh
- Lagrangian tracers throughout
 - Most significant tracers shown



Stress Coupling



$$\frac{1}{3} Y_o^2 = \frac{3}{4} S_{xx}^2 + S_{xy}^2$$

Y_o = Yield Stress

S_{xx} = Longitudinal stress deviator

S_{xy} = Shear stress deviator

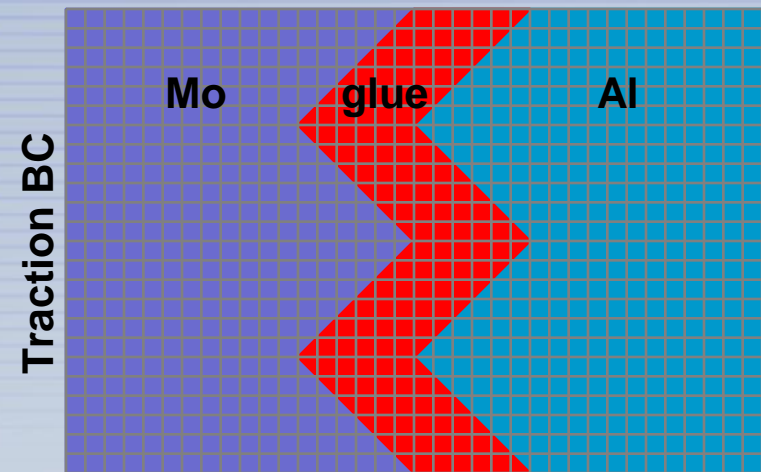
- **For inelastic materials, deviatoric longitudinal and shear stress are:**
 - Coupled through yield function
 - Limited by maximum yield stress
- **Sample probed at peak yield stress**
 - Forward shear wave arrives at sample during peak compression
- **Due to coupling, S_{xx} reduced to zero at yielding**

J.W. Swegle and L.C. Chhabildas, "Chapter 25: A Technique for the Generation of Pressure-Shear Loading Using Anisotropic Crystals," pp. 401-415, in M.A. Meyers and L.E. Murr, Shock Waves and High Strain Rate Phenomena in Metals, Plenum Press, NY, 1981.



Transmission of shear at interface

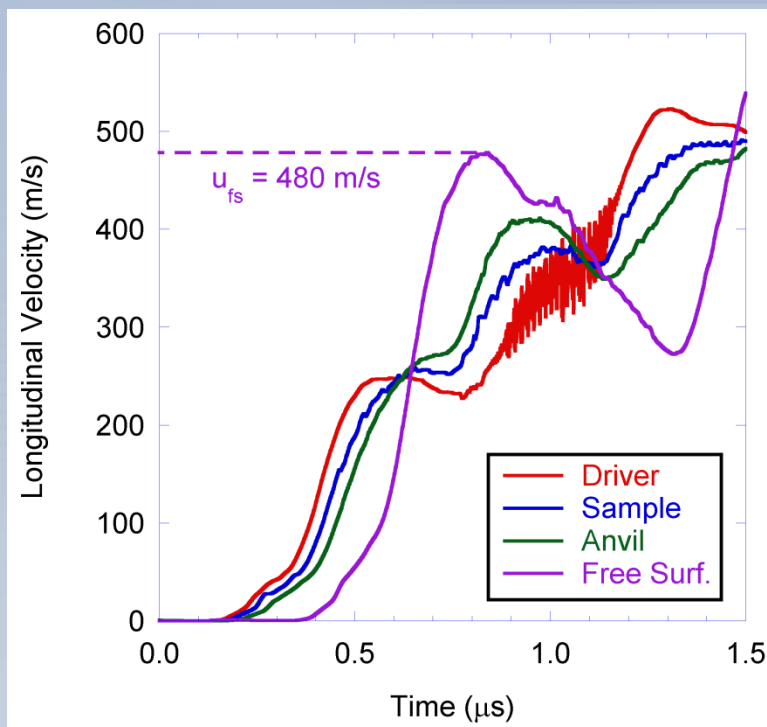
- **We conducted an investigation of surface roughness on shear transmission at a boundary**
- **Geometry**
 - Molybdenum driver – (partial)
 - Glue layer – 1 μm thick
 - Aluminum sample – (partial)
 - Mesh cell size – 0.05 μm
- **Interface**
 - 1, 2 or 3 μm peak-to-valley roughness
 - 2 μm wavelength
- **Traction boundary condition**
 - Determined from MHD simulation



- **Results**
 - No reduction in shear through this range of parameters
 - Glue compressed by longitudinal stress
 - Shear transmitted by interlocking peaks and valleys of surface roughness



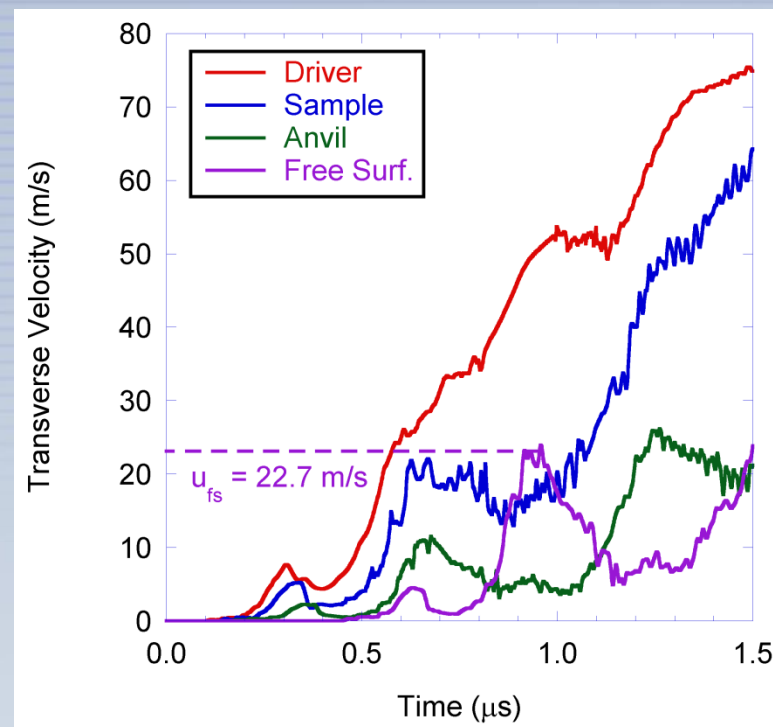
MHD Simulation Results: Free Surface Velocity



Longitudinal Free Surface Velocity

$$u_L = 0.480 \text{ km/s}$$

$$C_L = 7.99 \text{ km/s}$$



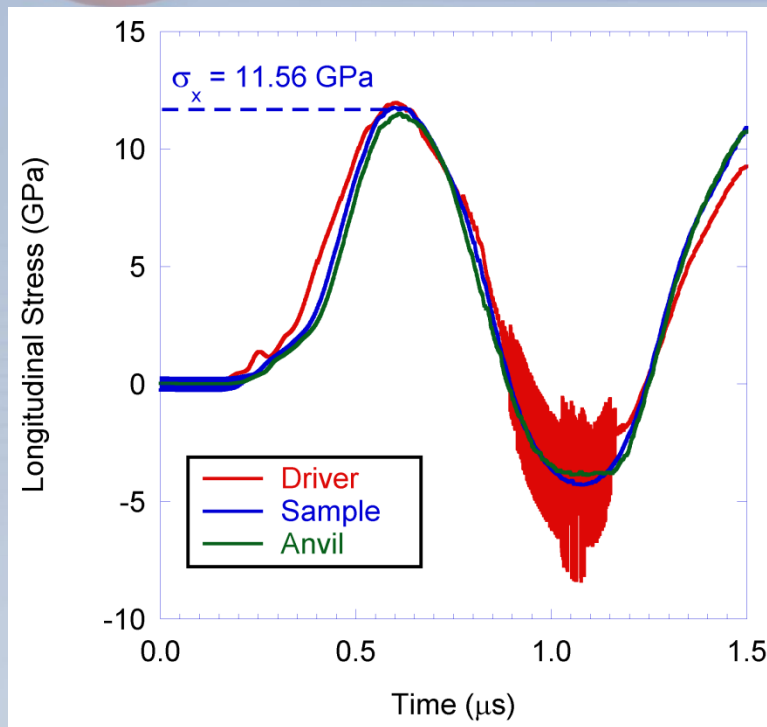
Shear Free Surface Velocity

$$u_S = 0.0227 \text{ km/s}$$

$$C_S = 5.56 \text{ km/s}$$



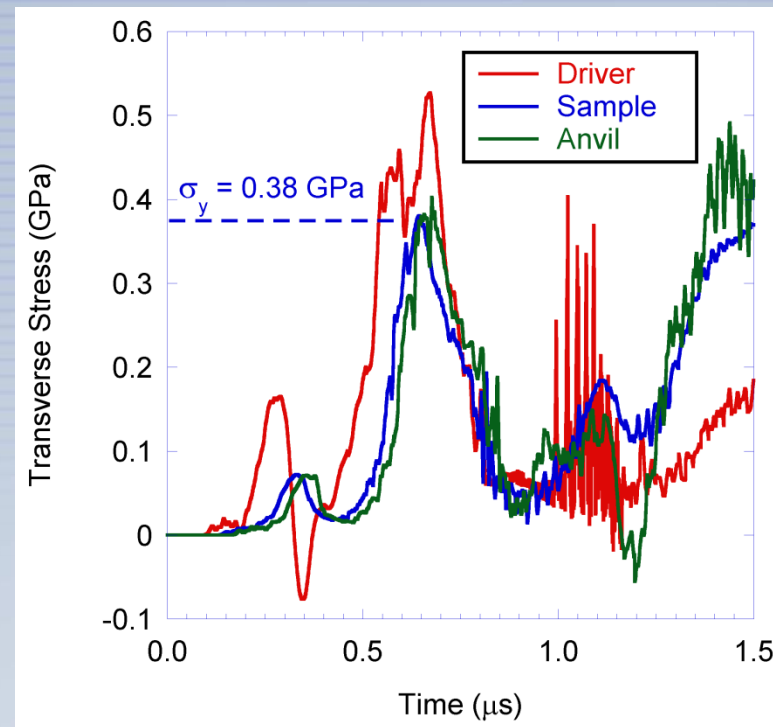
MHD Simulation Results: Tracer Longitudinal and Shear Stresses



Simulated Longitudinal Stress

$$\sigma = \rho C_L U_{PL} = \frac{1}{2} \rho C_L V_L$$

$$\sigma = 11.56 \text{ GPa}$$



Simulated Shear Stress

$$\tau = \rho C_S U_{PS} = \frac{1}{2} \rho C_S V_S$$

$$\tau = 0.38 \text{ GPa}$$

$$Y = \sqrt{3} \tau = 0.661 \text{ GPa}$$

$$Y_{\text{SGL}} = 0.660 \text{ GPa}$$

Self-consistent